

Notice of References Cited	Application/Control No. 10/748,941		Applicant(s)/Patent Under Reexamination DAVIS ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-2006/0017193	01-2006	Asthana et al.	264/173.1
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*	F	US-4,381,359	04-1983	Idel et al.	524/117
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	D	US-			
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	F	US-			
	G	US-			
	H	US-			
	I	US-			
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